



Patent
A04P3005-US1

Law

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: : Date: 12/20/04
Stevens, et al. :
Serial No: 10/813,200 : Group Art Unit: 2831
Filed: 3/29/04 :
For: "Process for Manufacturing High-Stability Crystalline : Examiner: unknown
Anodic Aluminum Oxide for Pulse Discharge Capacitors"

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

Sir:

This Information Disclosure Statement is being submitted pursuant to 37 C.F.R. §1.56 and §1.97.

The Examiner is requested to consider and make of record the references cited on the accompanying Form PTO-1449.

This Information Disclosure Statement should not be construed as a representation that a search has been made, nor should it be construed as an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in § 1.56(b).

If any fees are required, please charge them to Deposit Account No. 22-0265. This form is submitted in duplicate.

Respectfully submitted,

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